

NGC-212/12-1167

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

Patent Application

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Inventor(s): Raffi Nazare Elmadjian

Case No.: NGC-212/12-1167

Serial No.: 10/688,238

Filing Date: 10/18/2003

Title: WAFER ETCHING TECHNIQUES

Examiner  
Art Unit:

Ken Chan Chin  
1765

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop Amendment, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA, 22313-1450, at fax number (571) 273-8300, on February 2, 2006.

*James Milton*  
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Date of Signature: February 2, 2006

Commissioner for Patents  
Mail Stop Amendment  
Group Art Unit 1765  
Attention: Examiner Ken Chan Chin  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Fax Number (571) 273-8300

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*fcc 2/9/06*

*Entered per RCE  
2/20/06  
WA*

AMENDMENT AFTER FINAL OFFICE ACTION

Dear Sir:

This response is being filed in reference to the Final Office Action dated November 10, 2005 in connection with the above-designated application. A response to the Office Action is due February 10, 2006. Therefore, this Response is timely filed.